

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/670,264	<b>Applicant(s)/Patent under Reexamination</b> KIM ET AL.
	<b>Examiner</b> John L. Goodrow	<b>Art Unit</b> 1756

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
430	58.25	1/3/2006	JG
	72		
399	159		
552/299			